



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **NAKATA, Yoshihiro et al.**

Group Art Unit: **1771**

Serial No.: **10/807,174**

Examiner: **Hai VO**

Filed: **March 24, 2004**

P.T.O. Confirmation No.: 4205

For. **SILICON-BASED COMPOSITION, LOW DIELECTRIC CONSTANT FILM,
SEMICONDUCTOR DEVICE, AND METHOD FOR PRODUCING LOW
DIELECTRIC CONSTANT FILM**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: August 31, 2006

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated March 31, 2006, for two months, from June 30, 2006, to August 31, 2006.

Attached please find a check in the amount of \$450.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

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Atty. Docket No. **011293A**

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